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APPLICATION NO. FIRST NAMED INVENTOR FILING DATE ATTORNEY DOCKET NO. CONFIRMATION NO. 10/601,148 06/20/2003 Jeremy Donaldson 100110191-6 7231 12/14/2004 7590 **EXAMINER** HEWLETT-PACKARD COMPANY ALANKO, ANITA KAREN Intellectual Property Administration P. O. Box 272400 **ART UNIT** PAPER NUMBER Fort Collins, CO 80527-2400 1765

DATE MAILED: 12/14/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary		Application No.	Applicant(s)	1
		10/601,148	DONALDSON ET	TAL.
		Examiner	Art Unit	
		Anita K Alanko	1765	
The MAILING DATE of this con Period for Reply	nmunication appea	ars on the cover sheet v	with the correspondence ac	ddress
A SHORTENED STATUTORY PERIOD THE MAILING DATE OF THIS COMM  - Extensions of time may be available under the proafter SIX (6) MONTHS from the mailing date of this  - If the period for reply specified above is less than the light of the period for reply is specified above, the maxim  - Failure to reply within the set or extended period for Any reply received by the Office later than three meanned patent term adjustment. See 37 CFR 1.70.	MUNICATION.  visions of 37 CFR 1.136(a)  s communication.  hirty (30) days, a reply winum statutory period will a  or reply will, by statute, calconths after the mailing da	a). In no event, however, may a thin the statutory minimum of the apply and will expire SIX (6) MC apply and persone A	reply be timely filed  irty (30) days will be considered time  NTHS from the mailing date of this of the constant of the const	ly. communication.
Status				
1) Responsive to communication (	s) filed on			
2a) ☐ This action is <b>FINAL</b> .	2b)⊠ This ad	ction is non-final.		
3) Since this application is in cond	ition for allowance	e except for formal ma	tters, prosecution as to the	e merits is
closed in accordance with the p	ractice under <i>Ex j</i>	parte Quayle, 1935 C.I	D. 11, 453 O.G. 213.	
Disposition of Claims				
4) Claim(s) 1-32 is/are pending in	the application.			
4a) Of the above claim(s)		from consideration.		
5) Claim(s) is/are allowed.				
6)⊠ Claim(s) <u>1-32</u> is/are rejected.				
7) Claim(s) is/are objected to				
8) Claim(s) are subject to re	estriction and/or el	lection requirement.		
Application Papers				
9) The specification is objected to b	y the Examiner.			
10) The drawing(s) filed on is	are: a)∏ accept	ed or b) objected to	by the Examiner.	
Applicant may not request that any				
Replacement drawing sheet(s) inclu				
11)☐ The oath or declaration is objected	ed to by the Exam	niner. Note the attache	d Office Action or form PT	O-152.
Priority under 35 U.S.C. § 119				
12) Acknowledgment is made of a classical All b) Some * c) None of		ority under 35 U.S.C. §	§ 119(a)-(d) or (f).	
1. Certified copies of the price	rity documents ha	ave been received.		
2. Certified copies of the price			application No	
<ol><li>Copies of the certified cop</li></ol>			received in this National	Stage
application from the Intern		, , ,		
* See the attached detailed Office a	ction for a list of t	he certified copies not	received.	
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Attachment(s)				
) Notice of References Cited (PTO-892)			Summary (PTO-413)	
Notice of Draftsperson's Patent Drawing Revieus) Information Disclosure Statement(s) (PTO-144	w (PTO-948)	Paper No(s	s)/Mail Date  formal Patent Application (PTO-	450
Paper No(s)/Mail Date <u>5/13/04; 6/20/03</u> .	a 01 L 1 0/9R/08)		normal rateful Application (PTO)	-152)

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## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-12 are rejected under 35 U.S.C. 102(b) as being clearly anticipated by Hawkins et al (US 5,006,202).

Hawkins discloses a method and a print cartridge incorporating a print head die formed by the method comprising:

forming a first pattern masking layer 34 sufficient to expose a desired area of a first surface 12A of a substrate 10 (SiO<sub>2</sub>, Fig.3, col.5, lines 25-29);

after forming the first patterned masking layer, forming g asecond patterned masking layer 14 (Fig.6, col.6, lines 43-46) sufficient to expose less than the entirety of the desired area of the first surface (col.6, lines 37-42, 29C smaller than 29A);

forming a slot portion in the substrate through the second patterned masking layer (Fig. 7); and

removing additional substrate material to form a fluid-handling slot (Fig.9).

As to claim 2, Hawkins discloses a hard mask (thermal oxide, SiO<sub>2</sub>).

As to claim 3, Hawkins discloses forming a photoresist layer 30 (Fig.5, col.6, lines 26-

As to claim 4, Hawkins discloses etching the slot portion (col.6, lines 48-51).

As to claim 5, Hawkins discloses a through region positioned between two shallow regions (shelf 39, Fig.10).

As to claim 6, Hawkins discloses wet etching (col.6, lines 59-64).

As to claim 7, Hawkins discloses removing a portion of the second patterned masking layer (col.6, lines 56-57).

As to claim 9, Hawkins discloses a fluid-feed slot forming method comprising:

patterning a hard mask 34 on a substrate surface sufficient to expose a first area 12A of
the first surface;

forming a slot portion (Fig.7) in the substrate through less than an entirety of the first area of the first surface, the slot portion having a cross-sectional area at the first surface that is less than a cross-sectional area of the first area (since 29C is less than 29A); and,

after forming the slot portion, etching the substrate to remove material from within the first area to form a fluid-handling slot (Fig.9).

As to claim 10, Hawkins discloses to form a subset since the etched area is smaller than the original exposed area.

As to claim 11, Hawkins discloses covering the entire first substrate surface with the hard mask (Fig.1) and subsequently removing hard mask material from the first area of the surface (Fig.3).

Claims 13, 15-20 and 30-32 are rejected under 35 U.S.C. 102(b) as being clearly anticipated by Hawkins et al (US 6,303,042).

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Hawkins discloses a print head substrate forming method and a print cartridge incorporating a print head die formed by the method comprising:

exposing a first portion 520a of a substrate surface thorugh a hard mask 520 (Fig.5a); forming a photoresist 522 over the hard mask and the first portion;

removing at least some of the photoresist to expose a second portion of the substrate surface thorough which a slot portion is to be formed (Fig.5a);

dry etching the substrate through the photoresist sufficient to form the slot portion (Fig.5b, col.10, line 54); and,

after said dry etching, wet etching the substrate to form a fluid-handling slot (Fig.5c, col.10, line 60) without a re-entrant profile.

Claims 21-22 and 29 are rejected under 35 U.S.C. 102(b) as being clearly anticipated by Milligan et al (US 6,273,557).

Milligan discloses a printhead forming method and a print cartridge incorporating a print head die formed by the method comprising:

forming a fluid-handling slot in a substrate wherein a first portion of the sidewall is parallel (bottom surface of 502) to a first surface of the substrate, and a second portion of the sidewall is perpendicular to the first surface (sidewalls of 602, Fig.6C).

As to claim 22, Milligan discloses to form a slot portion 02 into a first surface 404 of a substrate (Fig.5B, col.5, lines 26-31); and,

etching the substrate to remove substrate material 602 proximate the slot portion to form a fluid-handling slot (Fig.6C, col.5, lines 37-47).

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Claims 21-26 and 29 are rejected under 35 U.S.C. 102(e) as being clearly anticipated by Miller et al (US 2003/0141279 A1).

Miller discloses a printhead forming method and a print cartridge incorporating a print head die formed by the method comprising:

forming a fluid-handling slot in a substrate wherein a first portion of the sidewall is parallel (bottom surface of slot) to a first surface of the substrate, and a second portion of the sidewall is perpendicular to the first surface (sidewalls of slot, Fig.9d or 9f).

As to claims 23-26, Miller discloses sand drilling as mechanical cutting and multiple dry etching steps (paragraphs [0059], [0057]), and patterning a hard mask [0056].

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 13-20 and 30-32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hawkins et al (US 6,303,042).

The discussion of Hawkins from above is repeated here. As to claim 14, Hawkins does not explicitly disclose to apply the hard mask over the entire substrate surface and removing hard mask from over the first portion. Hawkins merely discloses that a patterned layer is formed. Examiner takes official notice that deposition and removing is a conventional way to form masks. It would have been obvious to one with ordinary skill in the art to apply and remove the

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hard mask as cited in claim 14 because it is a conventional and useful technique for forming masks.

Claims 21-22 and 27-29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Milligan et al (US 6,273,557).

The discussion of Milligan from above is repeated here. As to claim 27, Milligan does not disclose to use lift-off. Examiner takes official notice that lift-off is a conventional technique for forming patterned layers. It would have been obvious to one with ordinary skill in the art to use lift-off to pattern hard mask in the method of Milligan because it is a conventional and useful technique for forming masks.

As to claim 28, Milligan does not disclose to use wet etching, rather Milligan discloses to use dry etching. It is conventional to etch by either wet or dry etching. It would have been obvious to one with ordinary skill in the art to use wet etching in the method of Milligan because it is a conventional technique for forming slots and because it is cheaper than dry etching.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anita K Alanko whose telephone number is 571-272-1458. The examiner can normally be reached on Mon-Fri until 2:30 pm (Wed until 11:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571-272-1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Anita K. Hanko

Anita K Alanko Primary Examiner Art Unit 1765